

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Kenichi Yokouchi et al.

Serial No.: 10/645,065

Filed: August 21, 2003

Confirmation No.: 6981

Date: December 26, 2006

Group Art Unit: 1763

Examiner: Sylvia Macarthur

For: SUBSTRATE PROCESSING APPARATUS AND SUBSTRATE PROCESSING
METHOD

VIA EFS-WEB

Commissioner for Patents

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SUBMISSION

Sir:

Submitted herewith are copies of search reports issued by a patent searching authority other than the PTO and the cited art together with a form listing the same for the convenience of the Examiner.

I certify that each item of information contained in this Submission was cited in a communication from a foreign patent office in a counterpart foreign application not more than 3 months prior to the filing of this Submission.

Credit card payment for the required filing fee of \$180.00 is being submitted via EFS-WEB.

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THIS CORRESPONDENCE IS BEING
SUBMITTED ELECTRONICALLY
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SYSTEM ON December 26, 2006.

Respectfully submitted,



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Enclosures

APPLICANT'S ART CITATION (Use several sheets if necessary)		Application 10/645,065		ORQS File No. P/2699-30		
		Applicant Kenichi YOKOUCHI et al.				
		Filing Date August 21, 2003		Group Art Unit 1763		
U.S. PATENT DOCUMENTS (not submitted for applications filed after 6/30/03)						
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate
	US-6,435,200	08-2002	Langen			
	US-2002/0148489	08-2002	Langen			
	US-2004/0020427	02-2004	Langen			
	US-2006/0144429	07-2006	Langen			
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	US-					
FOREIGN PATENT DOCUMENTS						
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation
						Yes No
	2000-343054	12-2000	Japan			corresponds to all U.S. Patent documents listed above for Langen
	7-122529	05-1995	Japan			X
	2003-37097	02-2003	Japan			X
	2002-246364	08-2002	Japan			corresponds to all U.S. Patent documents listed above for Engesser
	2002-75953	03-2002	Japan			X
	2002-75956	03-2002	Japan			X
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)						
		Office Action dated November 14, 2006 issued for Japanese Patent Application No. 2002-240891				
		Office Action dated November 14, 2006 issued for Japanese Patent Application No. 2002-283458				
Examiner		Date Considered				
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.						